



04-23-04

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Christophe MALEVILLE et al. Confirmation No. 6835  
Application No: 10/691,403 Group Art Unit: 2812  
Filing Date: October 21, 2003 Examiner:  
For: METHOD FOR PRODUCING A HIGH Atty. Docket No.: 4717-11700  
QUALITY USEFUL LAYER ON A SUBSTRATE

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Pursuant to applicants' duty of disclosure under 37 C.F.R. 1.56, applicants submit herewith five (5) references for the Examiner's review and consideration. These references were cited in the Preliminary Search Report and a copy is enclosed.

These references are listed on the enclosed Form PTO-1449. It is respectfully requested that these references be made of record in this application by the Examiner's completion and return of the PTO Form 1449. Also, the cited PCT application is an English equivalent to French application 2,797,713.

No fee is believed to be due for the filing of this statement as it is being submitted prior to an initial office action for this application. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Date:

4/21/04

Respectfully submitted,

Allan A. Fanucci (Reg. No. 30,256)

WINSTON & STRAWN  
CUSTOMER NO. 28765  
(212) 294-3311

Enclosures

NY:858379.1



<b>LIST OF REFERENCES CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.:	APPLICATION SERIAL NO.:
	4717-11700	10/691, 403
	APPLICANT:	
	Christophe MALEVILLE et al.	
	FILING DATE:	GROUP:
	October 21, 2003	2812

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	2002/0025604A1	2/2002	Tiwari	438	118	
	AB	6,593,212 B1	7/2003	Kub et al.	438	458	
	AC						
	AD						
	AE						
	AF						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AG	EP 0 954 014 A1	11/1999	Europe			X	
	AH	WO 01/15215	3/2001	PCT			X	
	AI							

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AJ	Jean-Pierre Colinge, "Silicon-On-Insulator Technology: Materials to VSLI", 2nd Edition" by, published by "Kluwer Academic Publishers", at pages 50 and 51.
	AK	
	AL	
	AM	

EXAMINER	DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.